

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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|---|---------------------|-------------|----------------|
| Applicant:  | Hyesook Hong et al. | Docket No.: | TI-35165       |
| Serial No.:   | 10/630,332          | Art Unit:   | 2812           |
| Filing Date:  | July 30, 2003       | Examiner:   | Pompey, Ron E. |
| Customer No.:   | 23494               | Conf. No.:  | 8758           |
| Title: MONITOR FOR VARIATION OF CRITICAL DIMENSIONS (CDs) OF RETICLES |                     |             |                |

**AMENDMENT UNDER 37 CFR 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated May 16, 2008. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no **Amendments to the Specification**.

**Amendments to the Claims** are reflected in the listing of claims that begin on page 2 of this paper.

There are no **Amendments to the Drawings**.

The **Remarks** begin on page 7.